Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number
IME-02-021	10/727,201

Applicant Kang Joon Mo et al.

Filing Date 12/03/03   **Group Art Unit**

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5199092	3/30/93	Stegmueller	385	50	1/31/92
	4954459	9/4/90	Avanzino et al.	437	228	7/3/89
	5510652	4/23/96	Burke et al.	257	752	10/6/94
	5863828	1/26/99	Snyder	438	437	9/25/96
	5851899	12/22/98	Weigand	438	427	8/8/96
	6258711	7/10/01	Laursen	438	633	4/19/99

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	"PECVD Growth Multiple Core Planar Waveguides with Extremely Low Interface Reflections and Losses" by Christian Laurent-Lund et al., IEEE Photonics Tech. Letters, Vol.10, No.10, Oct. 1998, pp. 1431-1433.

EXAMINER	DATE CONSIDERED 7/11/05

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